



AF/ICW

Docket No.: 204552030200  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Tetsuyoshi INOUE

Application No.: 10/679,497

Confirmation No.: 8843

Filed: October 7, 2003

Art Unit: 2828

For: SEMICONDUCTOR LASER DEVICE

Examiner: Ernest Unelus

**RESPONSE UNDER 37 CFR 1.116(b)**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 13, 2006, the following remarks and request for reconsideration are respectfully submitted.

**Remarks/Arguments** begin on page 2 of this paper.